CLAIMS

What is claimed is:

1	1. A method for replicating a monolayer comprising the steps of:
2	providing a first set of monomers;
3	forming the first set of monomers into a monolayer having a
4	desired pattern;
5	optionally polymerizing the first set of monomers, forming a first
6	optionally polymerized monolayer having a desired pattern;
7	attaching a second set of monomers to the first patterned,
8	optionally polymerized monolayer, forming a second monolayer attached to the
9	first patterned, optionally polymerized monolayer;
10	polymerizing the second monolayer, forming a second polymeric
11	monolayer attached to the first patterned, optionally polymerized monolayer; and
12	dissociating the second polymeric monolayer from the first
13	patterned, optionally polymerized monolayer.
1	2. A method for replicating a monolayer comprising the steps of:
2	providing a plurality of monomers;
3	providing a template for a monolayer to be replicated;
4	binding the plurality of monomers to the template, forming a
5	monolayer replicant;
6	polymerizing the monolayer replicant; and
7	disassociating the polymerized monolayer replicant from the
8	template.

3. The method of claim 2, wherein the template is a patterned substrate.

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4. The method of claim 2, wherein the template is a patterned monolayer in solution.

- 5. The method of claim 2, further including the step of using the polymerized monolayer replicant as a template for creation of at least one additional polymerized monolayer replicant.
- 6. The method of claim 2, wherein said monomers are nanoparticle ensembles.
- 7. The method of claim 6, wherein said monomers are selected from the group consisting of Hentriaconta-11,13,20,22-tetraynoic acid, Hentriaconta-11,13,20,22-tetraynoic acid amide, Triaconta-10,12,19,21-tetraynoic acid amide, Triaconta-10,12,19,21-tetraynoic acid, and other molecules of that family.
- 8. The method of claim 2, further including the step of selective mineralization of the replicant.
- 9. The method of claim 2, further including the step of electroless plating of the replicant.
- 10. The method of claim 2, further including the steps of nanoparticle adhesion and sintering of the replicant.
- 11. The method of claim 2, further including the step of growing a semiconductor upon the replicant.
- 1 12. A method for assembling a multilayer film comprising the steps of: 2 providing a layer template;

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3	providing a plurality of monomers;
4	binding the plurality of monomers to the template to form a layer;
5	polymerizing the formed layer;
6	using the polymerized layer as a template for a subsequent layer;
7	and
8	repeating the steps of binding, polymerizing, and using until a
9	multilayer film of desired thickness is obtained.
1	13. A method for replicating a monolayer comprising the steps of:
2	providing a first set of monomers having a first recognition
3	chemistry;
4	providing a second set of monomers having a second recognition
5	chemistry, the second recognition chemistry being complementary to the first
6	recognition chemistry;
7	forming a first type of template from a subset of the first set of
8	monomers;
9	binding a subset of the second set of monomers to the first type of
10	template to form a replicant of a first replicant type;
11	polymerizing the replicant of a first replicant type;
12	disassociating the polymerized replicant of a first replicant type
13	from the first type of template; and
14	utilizing the polymerized replicant of a first replicant type as a
15	second template type for replicants of a second replicant type.
1	14. A method for replicating a two-dimensional patterned structure
2	comprising the steps of:
3	providing a plurality of monomer units having crosslinker arms;
4	providing a template of the two-dimensional patterned structure;
5	hinding the monomer units to the template:

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6	reacting the crosslinker arms to bind the monomer units to each
7	other to form a two-dimensional replicant; and
8	disassociating the two-dimensional replicant from the template.
1	15. A method for forming a patterned layer of metal on a surface comprising
2	the steps of:
3	providing a surface having thereon a patterned layer of a
4	photoresist material, portions of the surface not being covered by the photoresist
5	material;
6	attaching metallic nanoparticles to the portions of the surface not
7	covered by the patterned layer of the photoresist material; and
8	melting the metallic nanoparticles, thereby forming a layer of the
9	metal having a pattern complementary to the patterned layer.
1	16. A method for replicating a multi-component pattern comprising the steps
2	of:
3	providing a plurality of sets of monomers having recognition
4	chemistries;
5	providing a template having a plurality of regions, each region
6	being complementary to a different set of monomers;
7	binding a set of monomers to each region to form a multi-
8	component replicant;
9	polymerizing the multi-component replicant; and
10	disassociating the multi-component replicant from the template.

inorganic materials to the multi-component replicant.

17.

The method of claim 16, further including the step of binding a plurality of

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- 18. The method of claim 17, wherein at least one of the inorganic materials is metallic.
- 19. The method of claim 16, further including the step of selective mineralization of the multi-component replicant.
- 20. The method of claim 16, further including the step of electroless plating of the multi-component replicant.
- 21. The method of claim 16, further including the step of growing a semiconductor upon the multi-component replicant.
- 1 22. A family of molecules exemplified by Hentriaconta-11,13,20,22-
- 2 tetraynoic acid, Hentriaconta-11,13,20,22-tetraynoic acid amide, Triaconta-
- 3 10,12,19,21-tetraynoic acid amide, and Triaconta-10,12,19,21-tetraynoic acid, the
- 4 molecules having two diacetylene units linked by a methylene chain of from 1 to
- 5 20 carbons to form a bis(diacetylene) unit, an alkyl chain of from 1 to 20 carbons
- 6 terminating in an inert functionality such as a methyl on one end of the
- 7 bis(diacetylene) unit, and an alkyl chain of from 1 to 20 carbons terminating in an
- 8 amide or carboxylic acid at the other end of the bis(diacetylene) unit.